



**RESPONSE UNDER 37 C.F.R. § 1.116  
EXPEDITED PROCEDURE - EXAMINING GROUP 2800**

PATENT

I hereby certify that on the date specified below, this correspondence is being deposited with the United States Postal Service as first-class mail in an envelope addressed to Mail Stop Amendment, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

Date

July 17, 2006

Phoebe E. Pogson

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Appl. No. : 10/075,640	Confirmation No. : 9841
Applicant : Michael Nuttall and Garry Anthony Mercaldi	
Filed : February 13, 2002	Attorney Docket No.: 500803.02
Art Unit : 2818	Customer No. : 27,076
Examiner : David Vu	
Title : METHOD FOR ENHANCING VERTICAL GROWTH DURING THE SELECTIVE FORMATION OF SILICON, AND STRUCTURES FORMED USING SAME	

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Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

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Sir:

Applicants acknowledge receipt of the Office Action dated May 16, 2006.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks begin on page 4 of this paper.